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| SERIAL NUMBER 10/617,767 | FILING DATE 07/14/2003 RULE | CLASS 438 | GROUP ART UNIT 2822 | ATTORNEY DOCKET NO. 249/349 |
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APPLICANTS

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** CONTINUING DATA ***** no ne OK

** FOREIGN APPLICATIONS *****

REPUBLIC OF KOREA 2002-42763 07/20/2002 yes OK

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 10/17/2003

| Foreign Priority claimed | <input checked="" type="checkbox"/> yes <input type="checkbox"/> no | STATE OR COUNTRY KOREA, REPUBLIC OF | SHEETS | TOTAL | INDEPENDENT |
|--|---|---|---------|--------|-------------|
| 35 USC 119 (a-d) conditions met | <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance | | DRAWING | CLAIMS | CLAIMS |
| Verified and Acknowledged <i>Chun Hyun Lee</i> Examiner's Signature | <i>CK</i> Initials | | 8 | 15 | 1 |

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TITLE

Deposition method of a dielectric layer

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|------------|---|
| | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of |
| FILING FEE | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT |